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	Filing Date		2008-06-02	
	First Named Inventor	Ejaz HUQ et al.		
	Art Unit	3427		
	Examiner Name	Gunnar Gissel		
	Attorney Docket Number	17495-63261		

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	1	Que, Lon et al; "Bent-Beam Electrothermal Actuators - Part I: Single Beam and Cascaded Devices," Journal of Microelectromechanical Systems, Vol. 10, No. 2, June 2001	<input type="checkbox"/>
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